

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants :Syouji NOGAMI et al. Group Art Unit : 2813
Appl. No. : 10/562,235 Examiner : Sonya D. McCall Shepard
Filed : October 31, 2006 Confirmation No. : 8539
For : MANUFACTURING METHOD OF SEMICONDUCTOR WAFER
AND SEMICONDUCTOR WAFER MANUFACTURED BY THIS
METHOD

AMENDMENT UNDER 37 C.F.R. 1.111

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Service Window, Mail Stop **AMENDMENT**
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir:

In response to the Office Action of July 17, 2009, please amend the above application as follows and reconsider the rejections in view thereof

Amendments to the Specification begin on page 2

Amendments to the Claims are reflected in the listing of claims beginning on page 6.

Remarks begin on page 14.